

<b>Notice of References Cited</b>	Application/Control No. 10/613,057	Applicant(s)/Patent Under Reexamination ZIEROLF, MICHAEL LEE	
	Examiner Christopher P. Schwartz	Art Unit 3683	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-			
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	D	US-			
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**FOREIGN PATENT DOCUMENTS**

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